

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kazuhiko OKAWA, Takayuki SAIKI

Application No.: 09/866,800

Filed: May 30, 2001

Docket No.: 109657

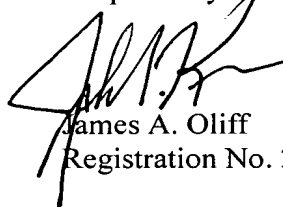
For: SEMICONDUCTOR DEVICE HAVING ELECTROSTATIC PROTECTION CIRCUIT  
AND METHOD OF FABRICATING THE SAMESUPPLEMENTAL INFORMATION DISCLOSURE STATEMENTDirector of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The Examiner's attention is directed to co-pending U.S. Patent Application Nos. 09/866,782, filed May 30, 2001 and 09/873,370, filed June 5, 2001, which are directed to related technical subject matter. The Examiner is respectfully requested to consider the cited applications and the art cited therein during examination of the present application.

Respectfully submitted,

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JAO:JSK/kap

Date: October 11, 2001

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